

(19)



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(11)

EP 0 576 007 B1

(12)

EUROPEAN PATENT SPECIFICATION

(45) Date of publication and mention
of the grant of the patent:
19.03.1997 Bulletin 1997/12

(51) Int. Cl.⁶: **B41J 2/16**

(21) Application number: **93110115.8**

(22) Date of filing: **24.06.1993**

(54) Method of forming a nozzle for an ink-jet printer head

Herstellungsverfahren einer Düse für einen Tintenstrahldruckkopf

Méthode pour la fabrication d'une buse pour une tête d'impression à jet d'encre

(84) Designated Contracting States:
CH DE FR GB IT LI NL SE

(30) Priority: **24.06.1992 JP 166041/92**
21.07.1992 JP 194107/92
12.05.1993 JP 134046/93

(43) Date of publication of application:
29.12.1993 Bulletin 1993/52

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(CANON INC.) 22 November 1989

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Description

This invention relates to a method of forming a nozzle for an ink-jet printer head.

An ink-jet printer head ejects ink in the form of ink droplets from a nozzle to write records on a recording medium.

In the case where water base ink is used as the ink, when the periphery of an opening of the nozzle has insufficient water repellency, the ink is liable to stick to the surface of the opening, thereby suffering a problem in that the straight-forwardness of ink droplets is impaired.

It is generally understood that, with respect to the water repellency of the periphery of a nozzle opening, a contact angle of 90 degree or more does not cause the straightforwardness of ink droplets to be impaired. Accordingly, the surface of a nozzle opening is usually coated by a water repellent agent.

As the method of forming such a coating layer, there have been proposed various methods such as the electrostatic spray coating method (Japanese Patent Unexamined Publication (Kokai) No. SHO 57-167765), the vacuum deposition method (Japanese Patent Unexamined Publication (Kokai) No. SHO 60-183161), the dipping method, the spray coating method, and the spin coating method, etc. All of these methods have a drawback that a water repellent agent may enter a nozzle to clog it or to impair the straightforwardness of ink droplets, thereby adversely affecting the printing quality.

As a method of providing water repellency to a surface of a nozzle opening without causing the nozzle to be clogged, Japanese Patent Unexamined Publication (Kokai) No. SHO 63-122560 discloses a method in which a flow path for ink is previously filled with a liquid or solid material and the coating process is then conducted, and Japanese Patent Unexamined Publication (Kokai) No. SHO 62-59047 discloses a method in which the coating process is conducted while ejecting air from a nozzle.

However, the former method has problems in that it is not easy to fill the flow path with a liquid or solid material and also that it is difficult to remove an excess of the filler material while keeping the flow path filled with the filler material. The latter method has a problem in that the periphery of the nozzle opening in which the water repellency must be exerted at the highest degree is affected by the air stream so as not to be sufficiently coated.

On the other hand, Japanese Patent Unexamined Publication (Kokai) No. HEI 3-207657 proposes a method in which an excimer laser is used as a nozzle forming means. This publication discloses also that, at the same time when a nozzle is formed, a water repellent layer formed on the periphery surface of the nozzle opening is removed by an excimer laser. Teflon may be used as a water repellent agent which can be removed by an excimer laser, but has a drawback that, when wiped, it is easily peeled off from the surface of the nozzle. A silicone resin cannot be superposed on a resin which can be ablated by an excimer laser. A silicone resin can be strongly bonded to glass. When glass is used as the material of the nozzle forming member, however, there arise problems in that it is difficult to form a nozzle and that glass dissolves in a long-term use.

Further, EP-A-468 712 discloses a manufacturing method for an ink jet recording head in which a water repellent film is formed on an orifice plate and discharge parts are bored in the orifice plate by the use of a laser beam. The film contains a polymer having a fluorine heterocyclic structure in the principle claim and has a thickness greater than 0.1 μ m. The laser beam is applied from a backside of the orifice plate after treating the surface of the orifice plate with the water repellent film.

It is therefore the object of the present invention to overcome the drawbacks of the above described known methods of forming a nozzle for an ink-jet printer head. This object is solved by the method according to independent claim 1. Further advantageous features, aspects and details of the invention are evident from the dependent claims, the description and the drawings.

Generally speaking the invention relates to a method of forming a nozzle for an ink-jet printer head which ejects ink droplets to write records.

The invention provides according to a first aspect a method of forming a nozzle for an ink-jet printer head which can form a water repellent layer that exhibits superior adhesion to a nozzle forming member and that is excellent in abrasion resistance, in an appropriate thickness and without allowing the material of the layer to enter the nozzle.

According to another aspect, the invention provides a method of forming a nozzle for an ink-jet printer head which can form a thicker water repellent layer of a fluorine-containing polymer on a surface of a nozzle forming member.

In order to attain these aspects, in the method of forming a nozzle for an ink-jet printer head according to the invention, a coating layer made of a fluorine-containing polymer is formed on a surface of a nozzle forming member made of plastics which can be ablated by an excimer laser, the coating layer having a thickness at which the coating layer can be completely removed from a nozzle by the ablation of the nozzle forming member and which is at least 20 nm, and the excimer laser is then irradiated in the direction from the back of the nozzle forming member to a nozzle formation portion.

In another method of forming a nozzle according to the invention, a coating layer made of a fluorine-containing polymer is formed on a surface of a nozzle forming member made of plastics which can be ablated by an excimer laser, the coating layer having a thickness at which at least a part of the coating layer can be removed from a nozzle by the ablation of the nozzle forming member and which is 20 nm or more, a covering layer is formed on the coating layer, the covering layer made of plastics which can be ablated by the excimer laser, the excimer laser is irradiated in the direction

from the back of the nozzle forming member to a nozzle formation portion, and the covering layer is separated from the coating layer.

Figs. 1(a) to 1(d) show a process of forming a nozzle for an ink-jet printer head according to an embodiment of the invention;

Fig. 2 is a diagram showing an ink ejection test of an ink-jet printer head formed by the forming process;

Fig. 3 is a diagram showing a state of a formed nozzle in which the coating layer has an excess thickness;

Figs. 4(a) and 4(b) are diagrams showing a state of a formed nozzle in which the coating layer has an insufficient thickness; and

Figs. 5(a) to 5(d) show another process of forming a nozzle for an ink-jet printer head according to the invention.

Embodiments of the invention will be described with reference to the accompanying drawings.

Figs. 1(a) to 1(d) shows a process of forming a nozzle for an ink-jet printer head according to an embodiment of the invention.

First, an E-shaped nozzle forming member 1 is sandwiched by jigs 2a and 2b at the upper and lower sides of the member 1, and fixed thereto by screws 3 (Fig. 1(a)).

The nozzle forming member 1 is made of arbitrary plastics which can be ablated by an excimer laser, or plastics in which the photochemical reaction due to the irradiation of a strong UV laser produces high-density excited species in the irradiated portion and the etching is conducted by the force owing to the decomposition and scattering of the excited species. Specific examples of the plastics are polycarbonate, polysulfone, polyimide, polyether imide, polybenzimidazole, polyacetal, polyethylene, polyethylene terephthalate, polystyrene, polyphenylene oxide, phenolic resins, acrylic resins, epoxy resins, and ABS resins.

Then, the surface 4 of the nozzle forming member 1 is immersed in a solution of a fluorine-containing polymer which functions as a water repellent agent and consists of 40 wt.% of SYTOP 105P (manufactured by Asahi Glass Company Ltd.) and 60 wt.% of CT-solv. 100 (manufactured by Asahi Glass Company Ltd.), and is allowed to stand for a while. Thereafter, the nozzle forming member 1 is pulled out of the solution at the rate of 100 mm/min. The nozzle forming member 1 is then heated at 120 °C in an oven for about one hour to evaporate the solvent, thereby forming a coating layer 5 having a thickness of 20 to 700 nm on the surface 4 (Fig. 1(b)).

The fluorine-containing polymer which is used as a water repellent agent is preferably an amorphous fluorine-containing polymer. In addition to the above-described compositions, specifically, useful examples of the fluorine-containing polymer include: a fluorine-containing polymer such as polydiperfluoroalkylfumarate and Teflon AF (trademark of Du Pont); an alternating copolymer of fluorine-containing ethylene and hydrocarbon ethylene such as an alternating copolymer of diperfluoroalkylfumarate and styrene, an alternating copolymer of ethylene chloride trifluoride and vinyl ether, and an alternating copolymer of ethylene chloride tetrafluoride and vinyl ester, their analogues and derivatives; and Fumalite (trademark of Nippon Oil and Fats Co., Ltd.).

These amorphous fluorine-containing polymers are soluble in a fluorinated organic solvent. When one of them is dissolved in a solvent at an arbitrary concentration and then coated on plastics which can be ablated by an excimer laser, therefore, a uniform coating having an excellent adhesion to the plastics can be obtained.

In addition to the above-described dipping method, examples of the coating method of an amorphous fluorine-containing polymer include the spray coating method in which a solution is sprayed, the spin coating method in which one or several droplets of a solution are allowed to fall on the surface of a nozzle forming member and then the member is rotated at a high speed to form a coating, and the transfer method in which a solution is previously applied on a supporter such as rubber and the supporter is then pressed against the surface of a nozzle forming member to form a coating.

Alternatively, the surface on which the coating is to be formed may be exposed to an atmosphere of ozone and then subjected to a coating process. This surface cleaning process using ozone can remove contamination from the surface so as to improve the adhesion of the coating layer. An atmosphere of ozone can be obtained by an oxygen plasma or irradiation of ultraviolet. In order to improve the adhesion to the surface on which the coating is to be formed, a layer of a coupling compound may be formed between the coating layer and the surface. This formation may be conducted singly or together with the surface cleaning process using ozone.

Thereafter, the nozzle forming member 1 is detached from the jigs 2a and 2b. A KrF excimer laser beam having an oscillation wavelength of 248 nm and an energy density of 2.0 J/cm² is irradiated to nozzle formation portions from the back 6 of the nozzle forming member 1, thereby forming a nozzle 7 at each of these portions.

This irradiation causes the portions of the nozzle forming member 1 irradiated by the excimer laser to be subjected to a photochemical reaction to produce high-density excited species. The excited species are decomposed and scattered to etch the portions so that the nozzles 7 are accurately formed at the portions as shown in Fig. 1(c). The coating layer 5 on the nozzles 7 is blown away by the decomposed and scattered excited species.

When the coating layer 5 has a thickness greater than 700 nm, the blow-off due to the excited species cannot be sufficiently performed with the result that a web-like film 5a is formed at the periphery of the opening of the nozzle 7 as

shown in Fig. 3. When the coating layer 5 has a thickness less than 20 nm, also a portion of the coating layer 5 at the periphery of the nozzle 7 is blown away so that area 4a where no water repellent layer exists is formed as shown in Fig. 4.

Finally, a vibrating plate 8 for transmitting a pressure and a head formation part 9 having ink supply ports are adhered to the thus formed nozzle forming member 1 (Fig. 1(d)), and piezoelectric elements 10 are adhered to the vibrating plate 8, thereby constituting an ink-jet printer head 11.

The coating layer 5 made of a fluorine-containing polymer had a contact angle of 100 deg. or more with respect to water. There was no clogging of the nozzle 7 caused by the coating layer 5, and no failure in formation and shaping of the nozzle 7.

Embodiment 1

The thickness of the coating layer 5 formed by the dipping method described above was measured by a method in which the coating layer 5 was partly shaved off by a small piece of polysulfone and the level difference between the surface 4 exposed as a result of this shaving and the surface of the coating layer 5 was measured. The measurement showed that the thickness was about 300 nm. Using this head 11, ink 12 for the ink-jet printing and shown in Table 1 below was ejected from the nozzle 7. The ink was straightly ejected and flew without curving (0.5 deg. or less) and a high-quality recording image with a high printing accuracy was formed on a recording medium 14.

Table 1

Components	Weight Ratio
Direct Black 154	3 wt.%
Glycerin	5 wt.%
Ethanol	5 wt.%
Proxel (manufactured by ICI)	0.2 wt.%
Water purified by ion exchange	86.8 wt.%

The head was repeatedly wiped 5,000 times by a dust wiper made of silicone rubber. Even after this wiping test, the straightforwardness of ink droplets was not impaired and it was able to form a high-quality recording image with a high printing accuracy.

According to a dipping method using a solution functioning as a water repellent agent and consisting of 3.5 wt.% of AF1600 (manufactured by Du Pont) and 96.5 wt.% of FV-75 (manufactured by Sumitomo 3M Ltd.), a coating layer 5 having a thickness of about 850 nm was formed. Also in this case, excellent results similar to those mentioned above were obtained. Even after the wiping process of 10,000 times, the image quality was not changed.

According to this dipping method, a coating layer 5 having a thickness of about 800 nm was formed on a surface 4 of a nozzle forming member 1, and a nozzle was formed under the above-described conditions using an excimer laser. In this case, as shown in Fig. 3, the coating layer 5 on the nozzle 7 was not sufficiently removed. When ink was ejected from the nozzle 7 of this head 11, ink droplets were affected by the coating layer 5 remaining in the form of a web-like film on the nozzle 7, to be curved by 2 to 8 deg., with the result that a high-quality recording image was not formed on a recording medium 14.

Embodiment 2

A surface 4 of a nozzle forming member 1 made of polycarbonate was irradiated for 10 minutes by UV light having a wavelength of 200 nm. Thereafter, one or several droplets of a solution of the composition listed in Table 2 below were allowed to fall on the surface, and the spin coating was conducted at 3,000 r.p.m. for one minute to coat the surface. The nozzle forming member 1 was heated at 80°C for one hour to evaporate the solvent, thereby forming a coating layer 5 having water repellency on the surface 4.

Table 2

Components	Weight Ratio
$ \begin{array}{ccccccc} & \text{X1} & \text{H} & \text{H} & \text{H} & & \\ & & & & & & \\ - & \text{C} & - & \text{C} & - & \text{C} & - & \text{C} & - \\ & & & & & & & & \\ & \text{H} & & \text{X1} & & \text{H} & & \text{C}_6\text{H}_5 & \text{n} \end{array} $	0.3 wt. %
FC-77 (manufactured by Sumitomo 3M Ltd.)	99.7 wt. %

The nozzle forming member 1 was irradiated from its back by a KrF excimer laser beam having an oscillation wavelength of 248 nm and an energy density of 2.0 J/cm², thereby forming a nozzle.

The coating layer 5 formed by the spin coating method had a contact angle of 100 deg. or more with respect to water. There was no clogging of the nozzle 7 caused by the coating layer 5.

The coating layer 5 formed by this method had a thickness of 30 nm. When ink was ejected from the nozzle 7 of the head 11, ink droplets were straightly ejected and flew without curving so that a high-quality recording image was formed on a recording medium 14.

The head was repeatedly wiped 2,000 times in the same manner as Embodiment 1. Even after this wiping test, it was able to form a high-quality recording image with a high printing accuracy.

According to this spin coating method, a coating layer 5 having a thickness of about 15 nm was formed on a surface of a nozzle forming member, and a nozzle was formed under the above-described conditions. In this case, as shown in Fig. 4(a), the portion of the coating layer 5 surrounding the nozzle 7 was broken. When ink was ejected from the nozzle 7 of this head 11, ink stuck to the surface 4 in the periphery of the nozzle 7. This caused the ink ejection direction to be curved by 3 to 5 deg., resulting in that a high-quality recording image was not formed.

As seen from the embodiments described above, it was confirmed that, when the coating layer 5 made of a fluorine-containing polymer and having a thickness of 20 to 700 nm is formed on the surface 4 of the nozzle forming member 1, the subsequent formation of the nozzle 7 using an excimer laser can form a nozzle which is free from ingress of the coating layer 5 and which have a sufficient coating in the periphery of its opening.

In the above embodiments, the nozzle forming member 1 itself utilizes the ablation. The ablation effect on the nozzle forming member 1 seems to be caused by the following process: The molecules constituting the irradiated portion are made unstable or enter the excited state or high energy state by the photochemical reaction due to the irradiation of an intense UV laser. Accompanying with this, in order that the excitation energy is diffused to stabilize the molecules, bonds of the molecules are broken to scatter the molecules. Even when an excimer laser having an energy density greater than the excitation energy is irradiated, therefore, the removal amount of a fluorine-containing polymer which is hard to excite cannot exceed a fixed level.

In the embodiments described above, accordingly, it is required to strictly control the upper limit of the film thickness so that the coating layer which is hard to excite is satisfactorily removed. In the embodiment described below and shown in Fig. 5, it is not required to conduct such a control and the film thickness can be increased, thereby further improving the abrasion resistance.

On a surface of a nozzle forming member 1 made of polysulfone, firstly, a coating layer 5 made of a fluorine-containing polymer is formed by the same dipping method as that in the first embodiment (Fig. 5(a)). The thickness of the coating layer 5 is restricted to such a degree that at least a portion of the coating layer 5 on a nozzle 7 can be removed by the ablation of the nozzle forming member 1.

Then, onto the coating layer 5, a film having a thickness of about 100 μm and made of plastics such as polyimide which can be ablated by an excimer laser is attached as a covering layer 15 (Fig. 5(b)).

Thereafter, a KrF excimer laser beam having an oscillation wavelength of 248 nm and an energy density of 2.0 J/cm² is irradiated to a nozzle formation portion from the back of the nozzle forming member 1 on which the coating layer 5 and the covering layer 15 are formed. This irradiation causes the molecules of the irradiated portion to generate high-density excited species. The excited species are decomposed and scattered to etch the portion so that the nozzle 7 is accurately formed in the portion. The decomposed and scattered excited species partly remove the portion of the

coating layer 5 covering the nozzle 7 as shown in Fig. 5(c). Furthermore, the portion of the covering layer 15 on the nozzle 7 is partly removed by the penetrating excimer laser, and the ablation of the covering layer 15 causes the portion of the coating layer 5 remaining on the nozzle 7 to be completely removed.

As shown in Fig. 5(d), finally, the covering layer 15 is peeled off from the upper face of the coating layer 5 to complete the nozzle formation process.

The coating layer 5 formed in the embodiment had a thickness of 2,000 nm. Using this head, ink was ejected from the nozzle 7. The ink was straightly ejected and flew without curving so that a recording image with a high printing accuracy was formed on a recording medium 14.

A nozzle 7 was formed by irradiating an excimer laser from the back of the nozzle forming member 1 on which the coating layer 5 having a thickness of 2,000 nm was formed but the covering layer 15 was not attached onto the layer. The coating layer 5 on the nozzle 7 was not completely removed. This caused ink to be curved by 2 to 8 deg., resulting in that a high-quality recording image was not formed.

From the above, it was confirmed that the coating layer 5 on the nozzle 7 can be removed not only by the ablation of the nozzle forming member 1 but also by the ablation of the covering layer 15.

Embodiment 3

On a surface 4 of a nozzle forming member 4 made of polyether imide, a coating layer 5 having a thickness of 800 nm was formed by the same spin coating method as that of the second embodiment. A covering layer 15 made of polyethylene terephthalate and having a thickness of 150 μ m was attached onto the coating layer.

Then, an excimer laser was irradiated from the back of the nozzle forming member 1 so as to conduct the same nozzle formation process as that described above, with the result that a head from which ink droplets can be ejected without curving was formed.

A film of polytetrafluoroethylen which had a thickness of 500 μ m and cannot be ablated by an excimer laser was attached onto a coating layer 5 that had the same thickness as that of the above-mentioned coating layer. Then, the same nozzle formation process as the process described above was conducted. As a result, the coating layer 5 on a nozzle 7 was not completely removed. This caused the ejection direction of ink to be bent.

From the above, it was confirmed that the covering layer 15 attached onto the coating layer 5 must be a film made of a material which can be ablated by an excimer laser.

As described above, according to the invention, after a covering layer made of plastics which can be ablated by an excimer laser is formed on a coating layer, the excimer laser is irradiated from the back of a nozzle forming member. Accordingly, even when the coating layer made of a fluorine-containing polymer is formed so as to have a sufficient thickness, the provision of the nozzle forming member and the covering layer can allow the coating layer to be surely removed.

Claims

1. A method of forming a nozzle for an ink-jet printer head, comprising the steps of:

preparing a nozzle forming member made of plastics which can be ablated by an excimer laser;

forming a coating layer comprising a fluorine-containing polymer on a surface of said nozzle forming member, said coating layer having a thickness at which at least a part of said coating layer can be removed from the nozzle by the ablation of said nozzle forming member and which is 20 nm or more;

forming a cover layer on said coating layer, said covering layer made of plastics which can be ablated by the excimer laser;

forming the nozzle by irradiating the excimer laser in a direction from a back of said nozzle forming member to a nozzle formation portion; and

after said nozzle formation step, separating said covering layer from said coating layer.

2. The method of forming a nozzle for an ink-jet printer head according to claim 1, wherein a material of said coating layer is an amorphous fluorine-containing polymer.

3. The method of forming a nozzle for an ink-jet printer head according to one of the preceding claims, wherein said coating layer has a thickness of 20 to 700 nm.

Patentansprüche

1. Verfahren zur Bildung einer Düse für einen Tintenstrahl Druckkopf mit folgenden Schritten:

- 5 Herstellung eines Düsenbildungselements, das aus Kunststoff hergestellt ist, welcher durch einen Excimerlaser abtragbar ist;
- Bildung einer Beschichtungsschicht mit einem fluorhaltigen Polymer auf einer Oberfläche des Düsenbildungselements, wobei die Beschichtungsschicht eine Dicke aufweist, bei welcher mindestens ein Teil der Beschichtungsschicht von der Düse durch Abtragung des Düsenbildungselements entfernbare ist, und welche 20 nm oder mehr beträgt;
- 10 Bildung einer Deckschicht auf der Beschichtungsschicht, wobei die Deckschicht aus Kunststoff hergestellt ist, welcher durch den Excimerlaser abtragbar ist;
- 15 Bildung der Düse durch Strahlung des Excimerlasers in einer Richtung von einer Hinterseite des Düsenbildungselements zu einem Düsenbildungsbereich; und
- 20 nach dem Düsenbildungsschritt Trennung der Deckschicht von der Beschichtungsschicht.

2. Verfahren zur Bildung einer Düse für einen Tintenstrahl Druckkopf gemäß Anspruch 1, wobei es sich bei einem Material der Beschichtungsschicht um ein amorphes fluorhaltiges Polymer handelt.
3. Verfahren zur Bildung einer Düse für einen Tintenstrahl Druckkopf gemäß einem der vorhergehenden Ansprüche, wobei die Beschichtungsschicht eine Dicke von 20 bis 700 nm aufweist.

Revendications

1. Procédé pour former une buse de tête d'imprimante à jet d'encre, comportant les étapes consistant à :
- 30 préparer un élément de formation de buse constitué de matière plastique qui peut être érodée par un laser à gaz noble ;
- former une couche de revêtement comportant un polymère contenant du fluor sur une surface dudit élément de formation de buse, ladite couche de revêtement ayant une épaisseur à laquelle au moins une partie de ladite couche de revêtement peut être enlevée de la buse par l'érosion dudit élément de formation de buse et qui est de 20 nm ou plus ;
- 35 former une couche de recouvrement sur ladite couche de revêtement, ladite couche de recouvrement étant en matière plastique qui peut être érodée par le laser à gaz noble ;
- former la buse par rayonnement du laser à gaz noble dans une direction partant de l'arrière dudit élément de formation de buse vers une partie de formation de buse ; et
- 40 après ladite étape de formation de buse, séparer ladite couche de recouvrement de ladite couche de revêtement.
2. Procédé pour former une buse de tête d'imprimante à jet d'encre selon la revendication 1, dans lequel un matériau de ladite couche de revêtement est un polymère amorphe contenant du fluor.
- 45 3. Procédé pour former une buse de tête d'imprimante à jet d'encre selon l'une quelconque des revendications précédentes, dans lequel ladite couche de revêtement a une épaisseur de 20 à 700 nm.

Fig. 1(a)

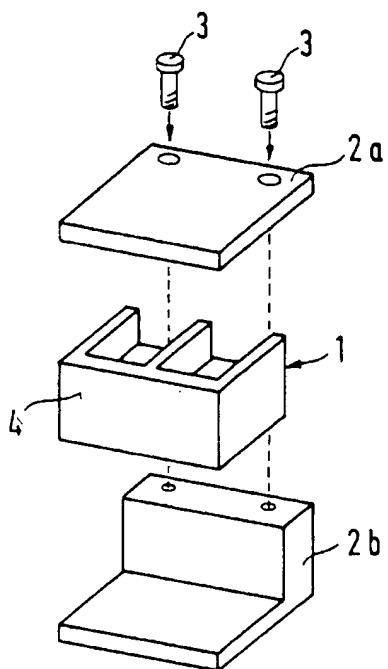


Fig. 1(c)

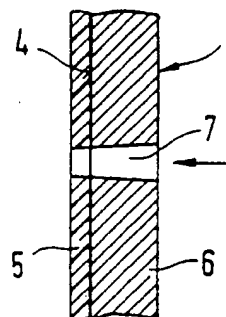


Fig. 1(b)

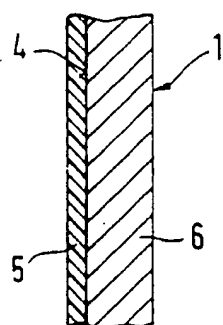


Fig. 1(d)

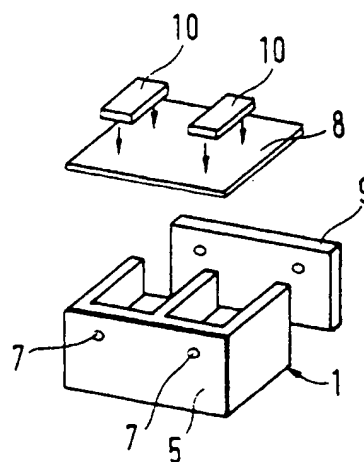


Fig. 2

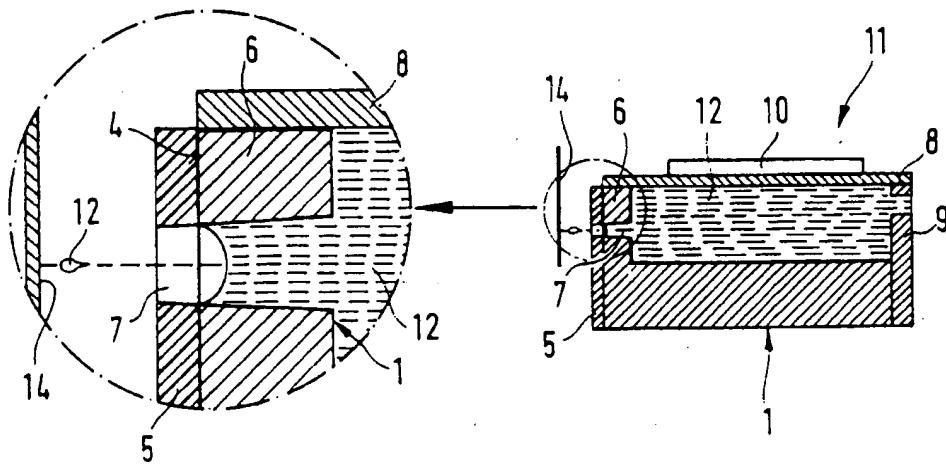


Fig. 3

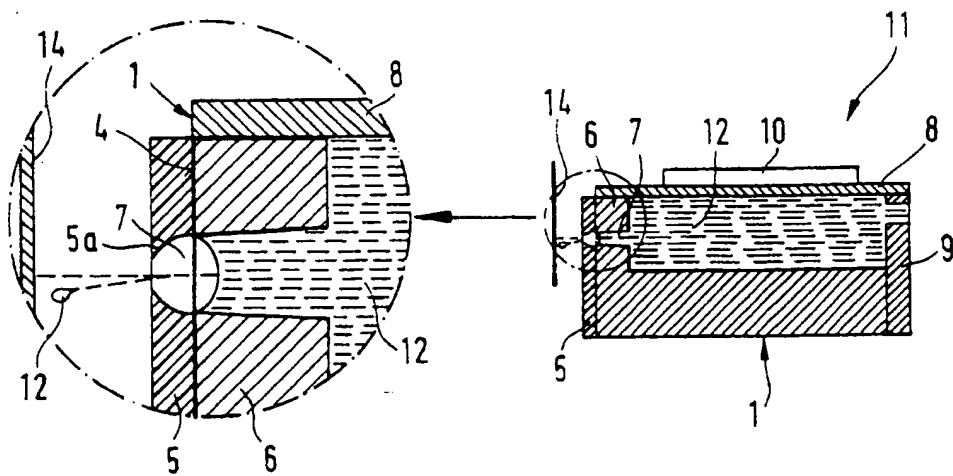


Fig. 4(a)

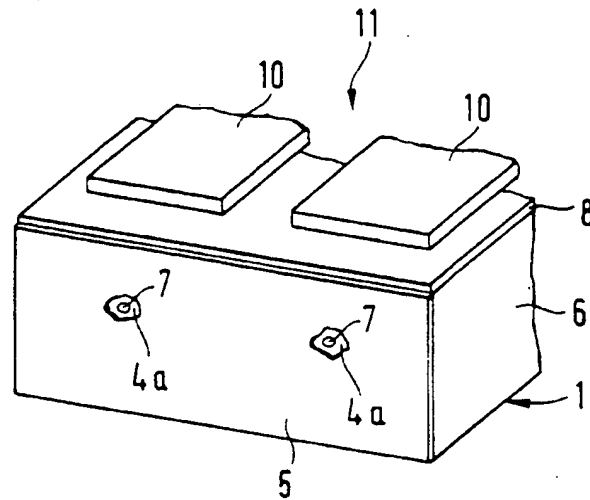


Fig. 4(b)

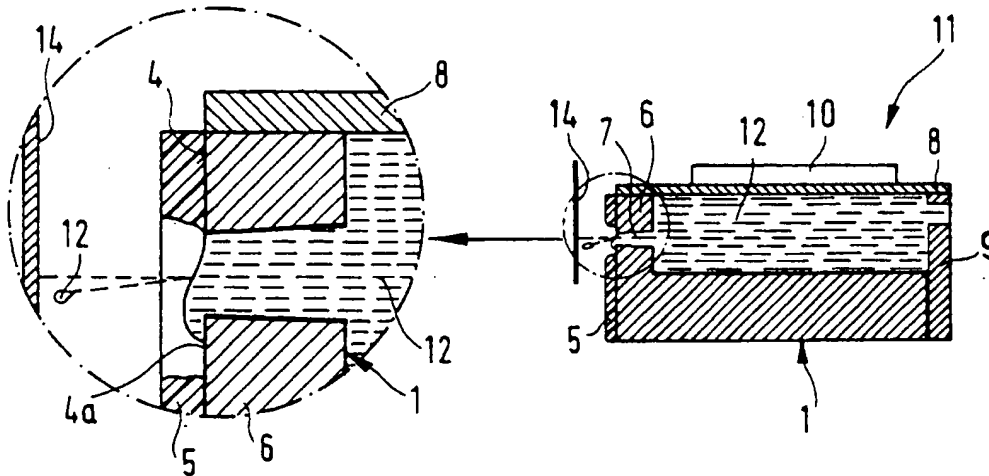


Fig. S(a)

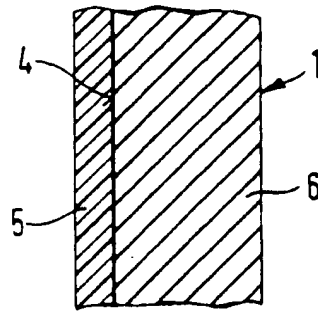


Fig. S(b)

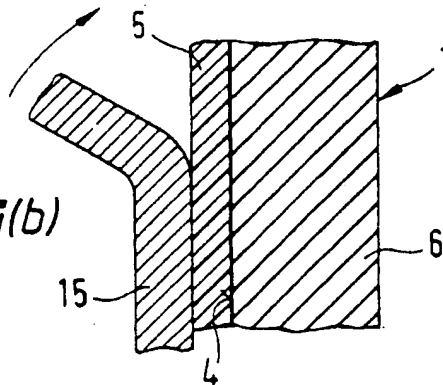


Fig. S(c)

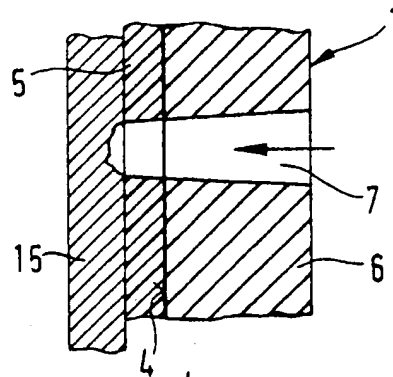
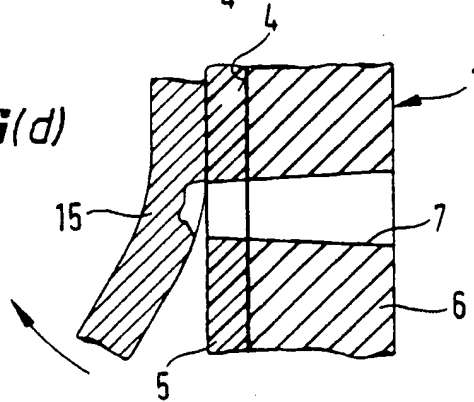


Fig. S(d)



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